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STEP's plan for understanding REBCO coated conductors in the Fusion Environment

1st International Workshop on Irradiation effects on high temperature superconductors (IREF23) William Iliffe, Simon Chislett-McDonald, Fiona Harden, Kirk Adams, James Tufnail, Chris Grovenor, Susannah Speller, Aidan Reilly, Stuart Wimbush, Ezzat Nasr

and)

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Requirements for Current Carriers in Fusion Magnets $P \propto B^4$ Central





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Anatomy of a REBCO Coated Conductor



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Properties of REBCO CC

 $J_c(B,\theta) = J_c(\tilde{B})$ [12]

 $\tilde{B} = B[\cos^2\theta + \gamma_m^{-2}\sin^2\theta]^{1/2}$











Initial Tape Properties Survey

Q. Can we use of a proxy measurement to predict properties at high B properties?

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Q. How to emulate neutron irradiation damage with ions?

Advice of G. S. Was *et al.*, "Emulation of reactor irradiation damage using ion beams" *Scr. Mater.*, vol. 88, pp. 33–36, 2014

- Use self-ions, where possible.
- To create **lattice damage**, ensure volume of interest has:
 - as-small-as-possible variation in the damage level
 - as-low-as-possible ion implantation concentration per bombarding ion over the volume of interest.
- To create the required **impurity concentration**:
 - ion energy(ies) needs to be minimised to avoid lattice damage but
 - still sufficient to push impurity ions to the desired location.



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What do Fusion Neutrons do to REBCO?

Q. What do fusion spectrum neutrons do to YBCO?



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In both spectra, 10% of the total damage due to 50-90keV Oxygen PKAs

Q. What do monoenergetic oxygen ions do to REBCO? (or any material)





Q. How does one create a uniform ion implantation profile? A. Use a Steinbach et al. energy filter



Implantation Concentration Experiment: Starting P energy: 7 MeV Dose: 7 x 10¹² P ions/cm²

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Concentration determined by SIMS



Q. What does the experiment look like?





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11

Q. What is the experiment set-up?



Silicon Implantation Experiment (SIMS)



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Sample Plate Assembled behind Filter on Beamline



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Q. Any change in T_c ?



- Sample 1 T_{c0} = 88.8 K YBCO
- + Sample 2 T_{c0} = 87.0 K (Gd/Y)BCO

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Q. Any change in J_c ?



Q. Any change in J_c ?



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